



JPW

Docket No.: 0033-0921P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Etsuo YAMAGISHI et al.

Application No.: 10/790,074

Confirmation No.: 2501

Filed: March 2, 2004

Art Unit: 2823

For: MATCHING UNIT FOR SEMICONDUCTOR
PLASMA PROCESSING APPARATUS

Examiner: W. M. Brewster

STATUS INQUIRY


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: JAN 31 2006

Respectfully submitted,

By 

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